

<b>Notice of References Cited</b>	Application/Control No. 10/665,982	Applicant(s)/Patent Under Reexamination ERK ET AL.	
	Examiner Eric B. Chen	Art Unit 1765	Page 1 of 1

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	B	US-6,793,836	09-2004	Tsung-Kuei et al.	216/83
	C	US-6,099,748	08-2000	Netsu et al.	216/99
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Wolf, Silicon Processing for the VLSI Era, 2002, Lattice Press, Vol. 4, pp. 322-324.
	V	ClearTech Technical Department, ClearTech Industries, Sodium Hydroxide Solutions MSDS, May 25, 2001.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.